Customer No. 20,995

Docket No.: SHIGA7.033APC

## IAP6 Rec'd PCT/PTO 22 NOV 2005

## INFORMATION DISCLOSURE STATEMENT

Applicant

Hada et al.

App. No

Unknown

Filed

Herewith

For

**RESIN FOR PHOTORESIST** 

COMPOSITION, PHOTORESSIT COMPOSITION AND METHOD FOR

FORMING RESIST PATTERN

Examiner

Unknown

Art Unit

Unknown

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 18 references to be considered by the Examiner. Also enclosed are 14 foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement. Please note the relevance of JP 7-234511, JP 11-012326, JP 2001-002735, JP 05-346668, JP 09-073173, JP 09-090637, JP 10-161313, JP 2002-311587 and JP 10-319595 is that they are cited in the subject specification and/or the International Search Report and Written Opinion from PCT priority application no. PCT/JP2004/008004. The relevance of JP 2000-3211771 is that is it cited in the International Search Report and Written Opinion from PCT priority application no. PCT/JP2004/008004. Please also note that US 5,968,713 corresponds to JP 09-73173 and JP 09-90637and US 6,656,659 corresponds to JP 10-319595.

This Information Disclosure Statement is being filed within three months of the filing date, and no fee is required.

10/557694

Appl. No. **Filed** 

Unknown Herewith

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The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 22 Nov. 2005

Daniel E. Altman

Registration No. 34,115

Attorney of Record

Customer No. 20,995

(949) 760-0404

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PTO/SB/08 Equivalent

	Application No.	Unknown
INFORMATION DISCLOSURE	Filing Date	Herewith 0 / 557694 Hada, Hideo
STATEMENT BY APPLICANT	First Named Inventor	Hada, Hideo
STATEMENT BY AFFLICANT	Art Unit	Unknown
(Multiple sheets used when necessary)	Examiner	Unknown
SHEET 1 OF 1	Attorney Docket No.	SHIGA7.033APC

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	1	US 2002/0150834 A1	10-17-2002	Yamamoto et al.	
	2	6,596,458 B1	07-22-2003	Sato et al.	
	3	5,968,713	10-19-1999	Nozaki et al.	
	4	6,656,659 B1	12-02-2003	Nozaki et al.	

	FOREIGN PATENT DOCUMENTS					
Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T <sup>1</sup>
	. 5	JP 7-234511	09-05-1995			
	6	EP 0 663 616 B1	10-30-2002	Fujitsu Ltd.		
	7	JP 11-012326	01-19-1999	Fujitsu Ltd.		Abstract
	. 8	JP 2000-321771	11-24-2000			
	. 9	JP 2001-002735	01-09-2001	Mitsubishi Rayon Co. Ltd		Abstract
	10	JP 04-039665	02-10-1992	Fujitsu Ltd.		Abstract
	11	JP 05-346668	12-27-1993	Fujitsu Ltd		Abstract
	12	JP 09-073173	03-18-1997	Fujitsu Ltd.		Abstract
	· 13	JP 09-090637	04-04-1997	Fujitsu Ltd.		Abstract
	` 14	JP 10-161313	06-19-1998	Fujitsu Ltd.		Abstract
	` 15	JP 10-319595	12-04-1998	Fujitsu Ltd.		Abstract
	· 16	JP 2002-311587	10-23-2002			

	NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Τ¹		
	17	International Search Report from PCT priority application serial no. PCT/JP2004/008004.			
	18	Written Opinion from PCT priority application serial no. PCT/JP2004/008004.	_		

2073538:vr111605

Examiner Signature Date Considered

<sup>\*</sup>Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

T<sup>1</sup> - Place a check mark in this area when an English language Translation is attached.